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Research Article

Low Threshold, Wide Dynamic Range, Tunable, All-Optical Self-Modulator Based on Fano Resonance and Out-of-Plane Coupling in a Slab Photonic Crystal with a Graphene Layer

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We demonstrate an all-optical modulator based on self-modulation in a one-dimensional slab photonic crystal (PhC) by using optical Kerr nonlinearity of graphene and Fano resonance effect. It has been shown that the effect of Fano resonance in a one-dimensional slab PhC for intensity enhancement can provide low threshold ($\sim 1 \text{ MW/cm}^2$), high frequency ($> 1 \text{ THz}$), and wide dynamic range ($> 3 \text{ THz}$) tunability for the all-optical self-modulator. Such a self-modulator can find applications in optical pulse generations, optical clocks, frequency shifting, and so forth.

1. Introduction

In recent years, research on THz sources for applying in THz science and technology is attracting great attention. Up to now various optical and electrical methods have been used for THz sources [1–11]; however at present, achieving compact, efficient, and economic sources remains a challenge to scientists and engineers [11–14]. One of the main optical methods for CW THz wave generation is heterodyne method that uses THz beat frequency of two frequency-locked laser beams with two different frequencies [10, 11]. In heterodyne method, the THz beat frequency can be tuned by changing the optical frequency of lasers. However this tuning is generally not so easy and requires a complex optical system. Also, other technical difficulties and high cost due to using two different lasers and problems due to optical alignments and frequency locking lead to the fact that this method is mainly used only in laboratories to characterize the THz antenna and devices.

To overcome the mentioned difficulties and complexity, we already proposed a compact size and easy tunable optical modulator based on all-optical self-modulation in a slab photonic crystal (PhC) waveguide with a single graphene

layer under the condition of in-plane illumination from the waveguide. In this structure, by using the ability of optical resonance at higher photonic bandgap edges with relatively high quality factor, we found all-optical sub-THz ($\sim 0.6 \text{ THz}$) self-modulation with relatively low input intensity ($\sim 15 \text{ MW/cm}^2$). We have also shown that the THz modulation frequency can be tuned easily by tuning input intensity with tuning sensitivity (tunability versus input intensity) of $0.04 \text{ THz}/(\text{MW/cm}^2)$. In that structure, however, a limitation is that one can have regular oscillation only in a small dynamic range around the threshold intensity so that the dynamic range of modulation frequency is relatively small (in the order of 0.1 THz). In addition, we have shown that, in that structure to achieve higher modulation frequencies ($\sim 3 \text{ THz}$), one have to use lower photonic bands with lower quality factors; however this leads to requiring much higher threshold intensities more than 100 MW/cm^2 .

To overcome the mentioned limitations, here we propose using out-of-plane coupling instead of in-plane coupling. In the case of out-of-plane coupling we use the ability of Fano resonance effect (instead of optical resonance at photonic bandgap edges) for achieving light intensity enhancement inside the PhC.

Considering page limit, the self-modulator is aimed for application in THz wave generation in this paper. However, the principle is the same for other applications in THz band and various applications in other frequency bands. We will show that Fano resonances of higher photonic bands can provide suitable quality factors to obtain relatively lower threshold intensity (in comparison with in-plane coupling) for achieving self-modulation, especially for modulation frequencies higher than 1 THz. In addition, we will show that instead of in-plane coupling, using out-of-plane coupling and Fano resonance effect provides larger dynamic range of modulation frequency more than 3 THz.

Furthermore, choosing out-of-plane illumination leads to much easier implementation without requiring optical alignment (compared with coupling inside the PhC waveguide). Thus the proposed THz self-modulator is expected to have relatively wide applications in THz science and technology due to its compactness, easy implementation, and wide dynamic range of frequency tuning.

2. Physical Model of the THz Self-Modulator Proposed

The schematic of the proposed structure is shown in Figure 1. The structure includes a SiO₂ substrate and a 1D silicon (Si) PhC with 9 periods and a single layer of graphene in the middle cell of the PhC. The filling factor ($F = w/a$) of Si in the PhC is 0.9 and the thickness of Si layer is $h = 0.5a$, where a is the period of the PhC that is selected by considering that the operation wavelength corresponds to the communication wavelength of $\lambda = 1550$ nm of the input laser wave and w is the width of each Si layer as shown in Figure 1. As we will show in the next sections, for our purpose the suitable normalized frequency (a/λ) is about 0.966, so we will have $a \approx 1497$ nm. The horizontal width of the graphene layer is the same as that of the silicon layer in the PhC unit cell. For the illumination, we consider a light polarized in z -direction inputted from the upside, as shown in Figure 1.

For fabrication of this structure, two extra processes are needed in comparison with usual Si PhC, that is, bonding and etching of graphene. Until now, various techniques have been developed for these processes which are also in rapid progress. For example, for graphene bonding one can use annealing [15, 16] or anodic bonding [17] and for graphene etching one can use chemical etching [18]. It is noticeable that, in the annealing bonding method, the interaction between graphene and substrate is due to the Van der Waals force that leads to a small band gap between valance and conductive bands of the graphene in the order of few 0.1 eV [19], so, as Gao et al. [19] show, this small perturbation has negligible effect on other parts of electronic band structure. Therefore, considering that our desired optical frequency is much higher than the induced band gap, the change in linear and nonlinear optical properties of graphene caused from graphene bonding can be neglected. This result also can be found from the fact that experimental results for nonlinear optical properties of multilayer graphene (that are bonded by Van der Waals force) in optical frequencies are the same as that of single layer of graphene [20].

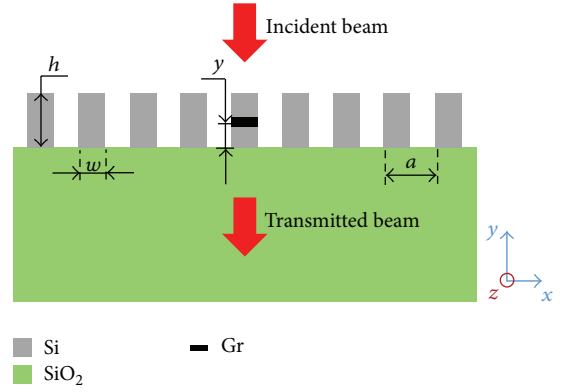


FIGURE 1: Schematic of the THz modulator. It consists of a one-dimensional (1D) slab PhC and a layer of graphene (Gr). A continuous infrared wave with a wavelength of 1550 nm is inputted from upside and self-modulated after transmission from the structure.

3. Theory and Calculation Method

In order to determine the suitable normalized frequency, we first calculate the transmission spectrum (versus normalized frequency) for the out-of-plane illumination with incident angle of zero. For calculation of transmission coefficient, we use an incident beam with a Gaussian profile with full width at half maximum (FWHM) of $5a$. This size has been selected to be comparable with the size of usual optical fibers. We calculate the transmission and then we perform nonlinear FDTD simulation to calculate the change of PhC transmission for different intensities of the pump beam at the selected normalized frequency.

We consider the dielectric constants of Si and SiO₂ as 12 and 2.1, respectively. Noting that the thickness of the graphene ($d_g = 0.34$ nm) is much smaller than the wavelength, thus we can consider the graphene and silicon around it (with a thickness equal to one mesh size of $0.02a \ll \lambda$) as a composite layer with an equivalent dielectric constant [21, 22] as

$$\epsilon_c = \epsilon_d + i \frac{\sigma_0}{\omega \epsilon_0 d_g} \rho, \quad (1)$$

where ϵ_d is the dielectric constant of Si, $\sigma_0 = 6.08 \times 10^{-5} \Omega^{-1}$ is the initial conductivity of the graphene, and ρ is the filling factor of the graphene inside the composite layer. ω is the angular frequency of light wave and ϵ_0 is the vacuum permittivity. The increment of the equivalent dielectric constant of the composite layer under the illumination of an input wave with intensity (I) is calculated by using the following equations:

$$\begin{aligned} \Delta \epsilon_c &= \rho \Delta \epsilon_g, \\ \Delta \epsilon_g &= \Delta (n_g^2), \\ \frac{d}{dt} \Delta n_g &= \frac{\beta n_2 I}{\tau_c} - \frac{\Delta n_g}{\tau_c}, \end{aligned} \quad (2)$$

where ϵ_g and n_g are the dielectric constant and refractive index of graphene, respectively, $\tau_c = 100$ fs [23] is the fall

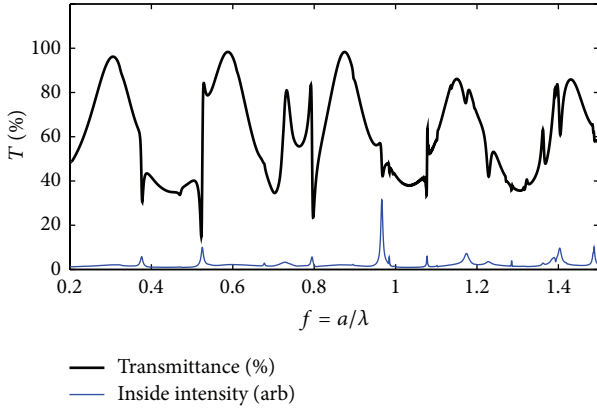


FIGURE 2: The transmission coefficient (T) and intensity inside the PhC (at the middle of the PhC) versus normalized frequency ($f = a/\lambda$) for the case of PhC without graphene.

time of the refractive index change, $\beta = 1/(1 + I/I_s)$, $n_2 = 10^{-7} \text{ cm}^2/\text{W}$, and $I_s = 600 \text{ MW}/\text{cm}^2$ [20].

As in our previous works [24], considering that there exists negative absorption nonlinearity of graphene that leads to reduction of its absorption with increasing light intensity, we neglect the effect of absorption nonlinearity and only consider Kerr nonlinearity of the graphene.

4. Results and Discussions

In Figure 2, the calculation result for the transmission coefficient of the PhC without graphene for normal incident angle (bold line) and the intensity at the position of the middle of the PhC (thin line) is shown. As can be seen, at the special normalized frequencies (f), some Fano resonances take place, leading to relatively sharp change in PhC transmittance. Also as can be seen the maximum intensity inside the PhC and equivalently the maximum quality factor is obtained for the Fano resonance at $f = 0.966$. The advantage of using Fano resonance with higher quality factor is its higher sensitivity to the change of the refractive index of the PhC in addition to providing higher intensity enhancement. These two factors help to decrease the required input intensity (threshold intensity) to achieve nonlinear effects.

The result of nonlinear FDTD simulations, for the PhC output power versus time for a number of fixed incident light intensities for normalized frequency of 0.966 (corresponding to the strongest Fano resonance), has been plotted in Figure 3.

As can be seen from Figure 3, for the intensities higher than $1.5 \text{ MW}/\text{cm}^2$ (we name it threshold intensity) self-modulation takes place. The regular oscillation takes place up to intensity of $\sim 10 \text{ MW}/\text{cm}^2$ and for much higher intensities (Figure 3(b)) the oscillation regularity decreases. Also by increasing the input intensity the modulation frequency increases. This ability provides an easy method for tuning the modulation frequency without requiring tuning optical frequency as it is needed in THz sources based on heterodyne method.

To study the modulation frequency tunability in more detail, in Figure 4 (red line), the modulation frequency (F_M) versus input intensity for the strongest Fano resonance ($f = 0.966$) is shown. In addition, for comparison, the result of self-modulation for the other Fano resonance at lower normalized frequency of $f = 0.527$ has been shown by blue line in Figure 4. As can be seen, for the case of strongest Fano resonance ($f = 0.966$) for intensities from 1.5 to $10 \text{ MW}/\text{cm}^2$, the modulation frequency increases from about 1 THz to $\sim 4 \text{ THz}$. That corresponds to tuning sensitivity of $dF_M/dI \approx 0.35 \text{ THz}/(\text{MW}/\text{cm}^2)$.

Thus, in comparison with our previous work [19], the dynamic range of modulation frequency tunability increases more than one order of magnitude ($\Delta F_M > 3 \text{ THz}$) and the tuning sensitivity (dF_M/dI) also increases about one order of magnitude in addition to decreasing the required threshold intensity.

Also, as can be seen from Figure 4, for Fano resonance at $f = 0.527$, the dynamic range of tunability of THz modulation frequency is approximately the same as for $f = 0.966$, but the required input intensity is increased strongly specially at higher modulation frequencies.

In order to study the effect of more graphene layers instead of one graphene layer in Figure 1, the results of the calculation of self-modulation frequency at normalized frequency of $f_0 = 0.966$ for various number of graphene layers (N) have been shown in Figure 5. As can be seen, for $N = 2$ and $N = 3$, the dynamic range of modulation frequency increases a little in comparison with $N = 1$ and the maximum regular modulation frequency is about 5 THz . Also, the threshold intensity for $N = 2$ and $N = 3$ decreases to less than $1 \text{ MW}/\text{cm}^2$ and the tuning sensitivity (dF_M/dI) increases up to $\sim 0.9 \text{ THz}/(\text{MW}/\text{cm}^2)$ and $\sim 1.3 \text{ THz}/(\text{MW}/\text{cm}^2)$, respectively. Thus, by using only 3 graphene layers we can obtain modulation frequency higher than 3 THz with input intensities less than $3 \text{ MW}/\text{cm}^2$.

For further study, the effect of more unit cells that contain a graphene layer (as shown in Figures 6(a) and 6(b)) on the modulation frequency and sensitivity has been shown in Figure 6(c). As can be seen, with the increase of the unit cells that contain a graphene layer (N_d), the dynamic range of modulation frequency and sensitivity (the slope of the curve F_M versus I) decreases and the threshold intensity increases.

The mechanism of the self-modulation can be described as follows. Consider the resonance condition that the optical frequency of the incident beam corresponds to the Fano resonance frequency. Thus the PhC behaves as an optical cavity. At first, the field in the cavity is 0 or very weak; no nonlinear effect exists; after a time period of building up field in the cavity due to nonzero quality factor of the cavity (or nonzero response time of the PhC), the field in the cavity reaches a high value and then nonlinear effects take place and refractive index of the cavity changes, resulting in detuning of the cavity (or Fano resonance frequency) that leads to decreasing the field in the cavity in comparison with the resonance condition (equality of Fano resonance frequency and light frequency); then after some time, the field in the cavity decreases to be very weak so that

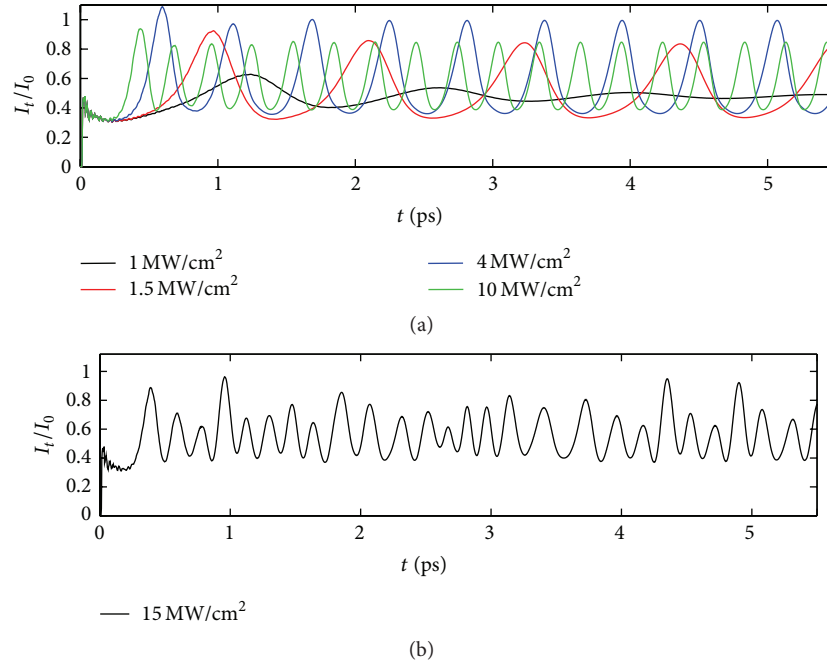


FIGURE 3: The transmission power versus time for a number of fixed average intensities of the incidence beam at the normalized frequency of $f_0 = 0.966$ (corresponding to the peak of the strongest Fano resonance). I_t is the transmitted intensity and I_0 is the incident intensity. The inset numbers show the incident intensities.

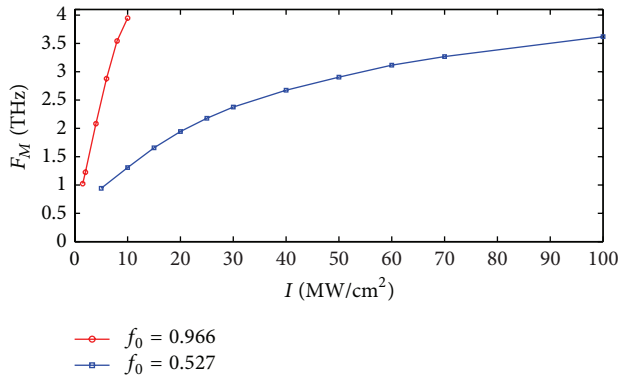


FIGURE 4: The modulation frequency (F_M) versus average intensity of the incidence beam for normalized frequency of $f_0 = 0.966$ (red line) and $f_0 = 0.527$ (blue line).

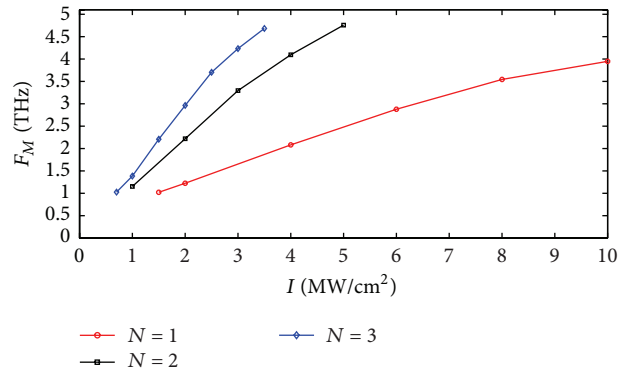


FIGURE 5: The modulation frequency (F_M) versus average intensity of the incidence beam for normalized frequency of $f_0 = 0.966$ (peak of the strongest Fano resonance in Figure 2) for various number (N) of graphene layers in the center cell in Figure 1.

the refractive index of the cavity returns or approaches to its initial value that leads the cavity to return to its initial resonance condition. Obviously, such a process would repeat in the system. Such a repeated process accounts for the self-modulation phenomenon in the proposed structure.

Also the contrary effect of the increasing of the graphene layers in one unit cell (Figure 5) and in multiunit cells (Figure 6) can be explained as follows. The increasing of the unit cells that contain a graphene layer (case A) leads to increasing of absorption of the PhC that leads to decreasing of the Fano resonance quality factor and thus decreasing of the sensitivity of the Fano resonance shift with the change of refractive index. But in the case of increasing the number of the graphene layers only in one unit cell (case B), although

the absorption increases (like case A), the average change of refractive index of the PhC is more than that in case A, because the intensity inside the middle cell is higher and also increases more due to the self-focusing effect. These two factors help to improve the sensitivity of the shift of the Fano resonance and thus the sensitivity of the modulation frequency

5. Conclusions

It has been shown that using Fano resonance effect and out-of-plane illumination in 1D slab PhCs that consist of a single layer of graphene can provide wide dynamic range

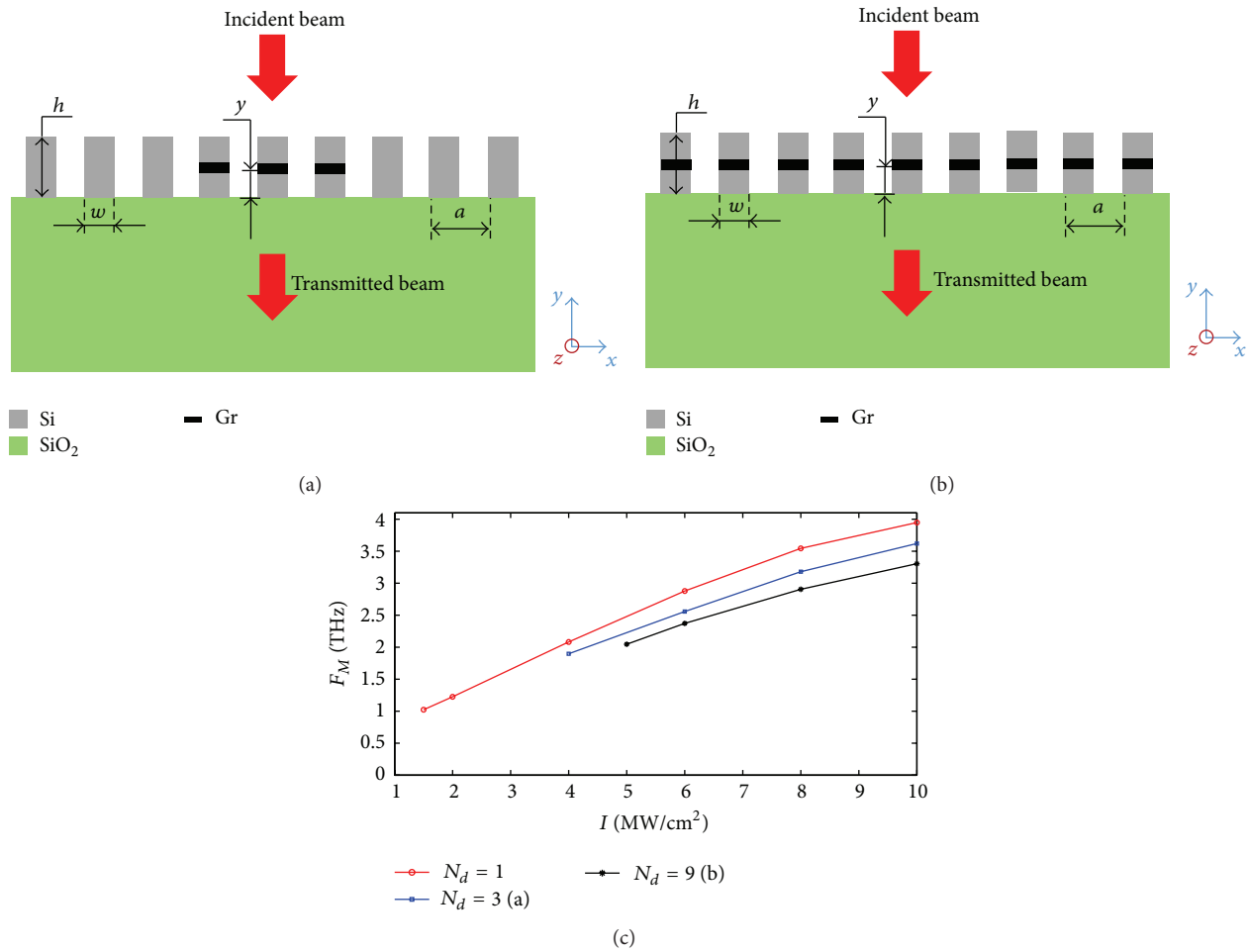


FIGURE 6: Self-modulators with 1, 3, and 9 silicon layers each embedded with a single graphene layer.

of tunability (>3 THz) from about 1 THz to ~ 4 THz self-modulation frequency with only tuning of input intensity (without requiring change of optical frequency). Also we have shown that using only 3 graphene layers can decrease the required input intensity less than 3 MW/cm^2 for modulation frequencies up to 4 THz.

Thus in comparison with our previous work that we used resonance effect at photonic band gap edges [19], using Fano resonance effect can improve the performance of self-modulation in nonlinear slab PhC in parameters including dynamic range of tunability, tuning sensitivity (dF_M/dI), and threshold intensity. In addition, in comparison with in-plane illumination, out-of-plane illumination can be used with easier PhC structure without requiring waveguide (for light coupling) and also easier implementation without requiring high-accuracy optical coupling and alignment. So, the proposed self-modulator can be expected to have wide applications in THz systems.

Conflict of Interests

The authors declare that there is no conflict of interests regarding the publication of this paper.

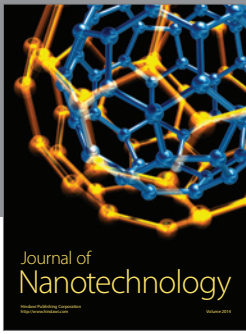
Acknowledgments

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